FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office					Attorney Docket Number 5308-157IP2			Serial No. 10/045,542
LIST	OF DO	OCUMENTS CITE	D BY APPLI					
(Use several sheets if necessary)					Applicants:	Das et al.		<u> </u>
O PE VC					Filing Date: October 26, 2001			Group 1762
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Examiner Initial		Document	Date	N	ame	Class	Subclass	Filing Date if Appropriate
7	1	5,885,870A	3/99	Maiti et al.		438	261	
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7	3	6,117,735	9/12/00	Ueno		438	268	
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		Document Number	Date	Со	untry	Class	Subclass	Translation Yes No
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	13	JP 11238742	8/31/99	Japan 🗸				Abstract
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	17	JP 2000106371	4/11/01	Japan 🗸			3	Abstract
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17 22	Lipkin et al. "Insulator Investigation on SiC for Improved Reliability," <i>IEEE Transactions on Electron Devices</i> . Vol. 46, No. 3, March 1999, pp. 525-32.					
7 23	Copy of International Search Report for PCT/US01/30715.					

Michael Barr

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